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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/648,044	08/25/2000	CHANDRA V. MOULI	MIO 0054 PA	6800
7590 05/04/2004 KILWORTH GOTTMAN HAGAN & SCHAEFF LLP ONE DAYTON CENTRE SUITE 500 ONE SOUTH MAIN STREET DAYTON, OH 45402-2023			EXAMINER	
			NADAV, ORI	
			ART UNIT	PAPER NUMBER
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Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)
	09/648,044	MOULI ET AL.
Office Action Summary	Examiner	Art Unit
	ori nadav	2811
The MAILING DATE of this communication is Period for Reply	appears on the cover sheet w	ith the correspondence address
A SHORTENED STATUTORY PERIOD FOR REITHE MAILING DATE OF THIS COMMUNICATIO - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a - If NO period for reply is specified above, the maximum statutory per - Failure to reply within the set or extended period for reply will, by state Any reply received by the Office later than three months after the material patent term adjustment. See 37 CFR 1.704(b).	N. R. 1.136(a). In no event, however, may a reply within the statutory minimum of thi iod will apply and will expire SIX (6) MO atute, cause the application to become A	reply be timely filed rty (30) days will be considered timely. NTHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133).
Status		
 1) ⊠ Responsive to communication(s) filed on 02 2a) ☐ This action is FINAL. 2b) ⊠ T 3) ☐ Since this application is in condition for allow closed in accordance with the practice under 	his action is non-final. wance except for formal mat	•
Disposition of Claims		
 4) Claim(s) 1-14,45 and 46 is/are pending in the 4a) Of the above claim(s) is/are without 5) Claim(s) is/are allowed. 6) Claim(s) 1-14,45 and 46 is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and 	drawn from consideration.	
Application Papers		
9) The specification is objected to by the Exam 10) The drawing(s) filed on is/are: a) a Applicant may not request that any objection to to Replacement drawing sheet(s) including the corr 11) The oath or declaration is objected to by the	accepted or b) objected to the drawing(s) be held in abeya rection is required if the drawing	nce. See 37 CFR 1.85(a). g(s) is objected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		
12) Acknowledgment is made of a claim for fore a) All b) Some * c) None of: 1. Certified copies of the priority docume 2. Certified copies of the priority docume 3. Copies of the certified copies of the papplication from the International Bur	ents have been received. ents have been received in A priority documents have beer eau (PCT Rule 17.2(a)).	Application No I received in this National Stage
* See the attached detailed Office action for a	list of the certified copies not	received.
Attachment(s)		
Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/Paper No(s)/Mail Date	Paper No	Summary (PTO-413) (s)/Mail Date Informal Patent Application (PTO-152)

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DETAILED ACTION

Claim Rejections - 35 USC § 102/103

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 1. Claims 1, 3, 5-9 and 45 are rejected under 35 U.S.C. 102(b) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over Akram et al. (WO99 31732A).

Akram teaches in figures 9 and 10 and related text a circuit structure comprising a semiconductor layer 12; a source region and a drain region 38, 40 in the semiconductor layer which are lightly doped and heavily doped with a first conductivity-type dopant; a channel region located between the source/drain regions;

a gate oxide layer 16e, 16f located on a surface of the channel region; and a gate electrode 20 comprising polysilicon and one or more additional layers 22 selected from the group consisting of metals, metal alloys, highly doped polysilicon, silicides, and

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polycides (polysilicon/metal silicide stacks) having first and second leading edges located on a portion of the gate oxide layer,

where a portion of the gate oxide layer defines a first overlap region which is beneath the gate electrode and adjacent the first leading edge and inward of the second leading edge and a second overlap region of the oxide layer located beneath said gate structure and adjacent said first overlap region and said second leading edge and adjacent the drain region, the overlap region comprising fluorine having an ion implant concentration higher than in said second overlap region and remaining oxide layer portions extending outwardly from both the first and second leading edges of the gate structure, and which can be effective to lower the surface electrical field in the overlap region, and including a pair of spaces 44e, 44f adjacent the gate electrode.

Akram does not explicitly state that the fluorine is effective to lower the surface electrical field in the overlap region. It would have been obvious to a person of ordinary skill in the art at the time the invention was made to use fluorine in Akram's device sufficient to lower the surface electrical field in the overlap region in order to improve the device characteristics.

Note that the broad recitation of the claims does not require that the overlap region has an ion implant concentration higher than all the remaining oxide layer portions extending outwardly from both the first and second leading edges of the gate structure.

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Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 2, 4, 12-14 and 46 are rejected under 35 U.S.C. 103(a) as being unpatentable over Akram.

Akram teaches substantially the entire claimed structure, as applied to claim 1 above, except using a fluorine concentration of about 1 E 18 atoms per cubic centimeter. Regarding claims 2, 4, 13 and 46, it would have been obvious to a person of ordinary skill in the art at the time the invention was made to use a fluorine concentration of about 1 E 18 atoms per cubic centimeter in Akram's device, since it is within the skills of an artisan in order to improve the characteristics of the device by routine experimentation and optimization. Note that differences in concentration or temperature do not support the patentability of subject matter encompassed by the prior art unless there is evidence indicating such concentration or temperature is critical. "[W]here the general conditions of a claim are disclosed in the prior art, it is not inventive to discover the optimum or workable ranges by routine experimentation." In re. Aller., 220 F.2d 454, 105 USPQ 233, 235 (CCPA 1955). See also. In re. Hoeschele., 406 F.2d 1403, 160 USPQ 809 (CCPA 1969). For more recent cases applying this principle, see. Merck & Co. Inc., v. Biocraft Laboratories Inc., 874 F.2d 804, 10 USPQ2d 1843 (Fed. Cir.),

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cert. denied, 493 U.S. 975 (1989), and In re Kulling, 897 F.2d 1147, 14 USPQ2d 1056 (Fed. Cir. 1990).

Regarding claims 12-14, it would have been obvious to a person of ordinary skill in the art at the time the invention was made to use Akram's transistor in a CMOS configuration in order to use the device in a specific application which requires a CMOS device.

3. Claim 10 is rejected under 35 U.S.C. 103(a) as being unpatentable over Akram in view of Admitted Prior Art (APA).

Akram teaches substantially the entire claimed structure, as applied to claim 1 above, except a gate electrode is comprised of a layer of polysilicon, a layer of titanium nitride deposited on the polysilicon layer, and a layer of tungsten deposited on the titanium layer. APA teaches in figure 1 a gate electrode is comprised of a layer of polysilicon 18, a layer of titanium nitride 20 deposited on the polysilicon layer, and a layer of tungsten 22 deposited on the titanium layer. It would have been obvious to a person of ordinary skill in the art at the time the invention was made to use a gate electrode comprising of a layer of polysilicon, a layer of titanium nitride deposited on the polysilicon layer, and a layer of tungsten deposited on the titanium layer in Akram's device, in order to reduce the contact resistance of the device.

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4. Claims 11-14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Akram (5,750,435) in view of Motoyoshi et al. (JP 6-53492).

Akram teaches substantially the entire claimed structure, as applied to claim 1 above, except using the transistor in a CMOS configuration.

Motoyoshi et al. use a transistor having a gate oxide comprising fluorine in a CMOS configuration. it would have been obvious to a person of ordinary skill in the art at the time the invention was made to use Akram's transistor in a CMOS configuration in order to use the device in a specific application which requires a CMOS device.

Regarding claim 11, Motoyoshi et al. teach in figure 7 a pair of conductive studs and an interlevel dielectric layer provided on the semiconductive layer, the interlevel dielectric layer have a pair of through holes, each accommodating one of each the pair of conductive studs, and one of each the pair of conductive studs contacting one of each the source/drain regions. it would have been obvious to a person of ordinary skill in the art at the time the invention was made to use a pair of conductive studs through an interlevel dielectric layer provided on the semiconductive layer, the interlevel dielectric layer have a pair of through holes, each accommodating one of each the pair of conductive studs, and one of each the pair of conductive studs contacting one of each the source/drain regions in Akram's device in order to operate the device in its intended use. Note that the device would not operate without external connections.

Regarding claim 13, it would have been obvious to a person of ordinary skill in the art at the time the invention was made to use a fluorine concentration of about 1 E 18 atoms per cubic centimeter in Akram's device, since it is within the skills of an artisan in order to improve the characteristics of the device by routine experimentation and optimization. Note that differences in concentration or temperature do not support the patentability of subject matter encompassed by the prior art unless there is evidence indicating such concentration or temperature is critical. "[W]here the general conditions of a claim are disclosed in the prior art, it is not inventive to discover the optimum or workable ranges by routine experimentation." In re Aller, 220 F.2d 454, 105 USPQ 233, 235 (CCPA 1955). See also In re Hoeschele, 406 F.2d 1403, 160 USPQ 809 (CCPA 1969). For more recent cases applying this principle, see Merck & Co. Inc. v. Biocraft Laboratories Inc., 874 F.2d 804, 10 USPQ2d 1843 (Fed. Cir.), cert. denied, 493 U.S. 975 (1989), and In re Kulling, 897 F.2d 1147, 14 USPQ2d 1056 (Fed. Cir. 1990).

Response to Arguments

Applicant argues that Akram et al. and Pan do not teach an overlap region having an ion implant concentration higher than the remaining oxide layer portions extending outwardly from both the first and second leading edges of the gate structure.

The broad recitation of the claims does not require the overlap region to have an ion implant concentration higher than all the remaining oxide layer portions extending outwardly from both the first and second leading edges of the gate structure. Clearly

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the overlap region of Akram et al. includes portions of lower concentration which are located and extend outwardly from both the first and second leading edges of the gate structure. Therefore, Akram et al. and Pan teach an overlap region having an ion implant concentration higher than the remaining oxide layer portions extending outwardly from both the first and second leading edges of the gate structure, as claimed.

Papers related to this application may be submitted to Technology center (TC) 2800 by facsimile transmission. Papers should be faxed to TC 2800 via the TC 2800 Fax center located in Crystal Plaza 4, room 4-C23. The faxing of such papers must conform with the notice published in the Official Gazette, 1096 OG 30 (November 15, 1989). The Group 2811 Fax Center number is (703) 308-7722 and 308-7724. The Group 2811 Fax Center is to be used only for papers related to Group 2811 applications.

Any inquiry concerning this communication or any earlier communication from the Examiner should be directed to *Examiner Nadav* whose telephone number is **(571) 272-1660**. The Examiner is in the Office generally between the hours of 7 AM to 4 PM (Eastern Standard Time) Monday through Friday.

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Any inquiry of a general nature or relating to the status of this application should be directed to the **Technology Center Receptionists** whose telephone number is **308**-**0956**

O.N. April 30, 2004 ORI NADAV
PATENT EXAMINER
TECHNOLOGY CENTER 2800